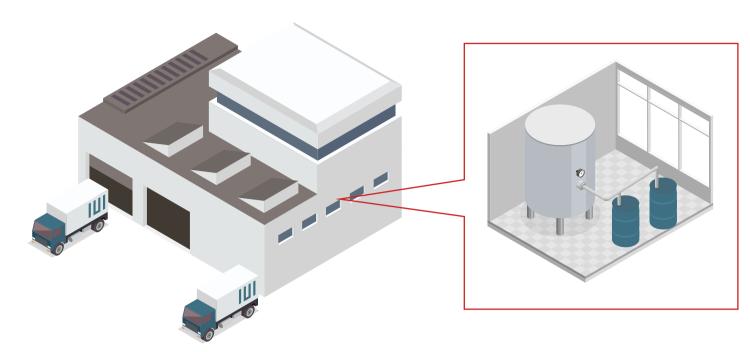
## Becoming a Strategic Chemical Supplier:

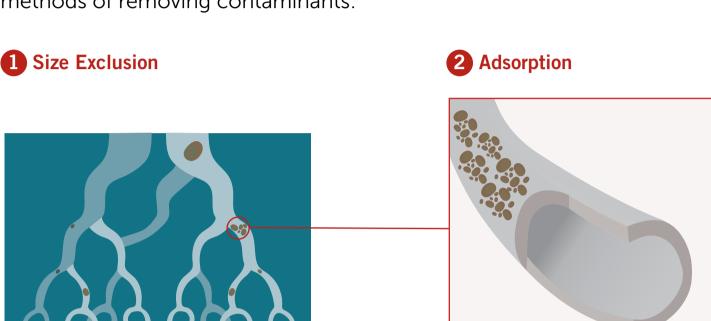
# The Fight for Semiconductor Material Manufacturing Purity

Chemical manufacturers are critical determinants of quality and efficiency in the semiconductor fabrication process. Fabs are increasingly looking for cleaner, more contaminant-free chemicals. They are also looking for processes that ensure cleanliness throughout the semiconductor materials supply chain. Their challenge is to meet new contamination targets while maintaining their operating models.



## FILTRATION VERSUS PURIFICATION

Clean chemicals result from stricter adherence to contamination control processes and technologies, meeting the specifications determined by the fab's intended usage and end product. There are two primary methods of removing contaminants:



#### UNDERSTANDING DOWNSTREAM COSTS OF CONTAMINATION

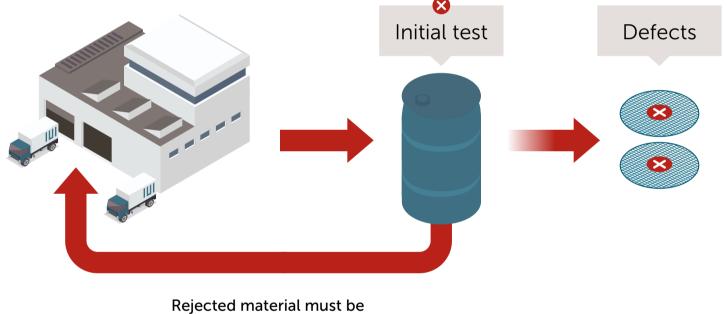
For a chemical supplier, there may be an immediate expense from contamination during production. The risk to the fab is compounded if the contaminated materials are put into use as well.

> after initial testing, it can cause expedited rework to meet delivery deadlines.

If the fab rejects a batch

chip failures or shutdowns in the fab, with shutdowns in the fab with escalated rework and waste disposal costs.

Undetected contamination can cause



COMPATIBILITY OF MATERIALS

returned by the fab at an

additional cost.

adverse reactions with filters, purifiers, and other materials in downstream use at the fab. Fabs, equipment makers, and chemical suppliers must collaborate openly and Chemical Filter

Specialized membrane and media modifications designed to promote absorption must be compatible with each chemical and blend to avoid



share information on usage to prevent

these types of interactions.



### customers. Aligned processes allow for responsive reactions to changing fab conditions and requirements, and often yield more effcient operation.



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